

Paper number 20051024

FORM HDP-1449 (Based on Form PTO-1449)

PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

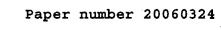
Sheet 1 of 1

ATTORNEY DOCKET No.	SERIAL NO.		
2115D-000939/DVD 09/775,069			
APPLICANT			
Gerard A. Mourou			
FILING DATE GROUP			
February 1, 2001	1725		

U.S. P	ATENT DO	CUMENTS				·
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.	/G.E./	5,637,244	06/10/1997	Erokhin		

FORE	IGN PATEN	IT DOCUMENTS	,				
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes 1	No
1.	/G.E./	JP 403 216 287 A	09/24/1991	Japan		- Abstract	

Examiner: /Geoffrey Evans/ Date Considered: 07/09/2007



FORMS P-1449 (Based on Form PTO-1449)

PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Sheet 1 of 1

ATTORNEY DOCKET No.	SERIAL NO.			
2115D-000939/DVD 09/775,069				
APPLICANT				
Gerard A. Mourou				
FILING DATE GROUP				
February 1, 2001 1725				

FORE	FOREIGN PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes	No
1.	/G.E./	JP 03216287 A	09/24/1991	Japan		Abstract	

OTHE	OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)				
Ref. Desig.	Examiner's Initials				
11 .	/G.E./	Mannion et al., "Ablation Thresholds in Ultrafast Laser Micro-Machining of Common Metals in Air, Proceedings of SPIE, Vol. 4876 (2003), pages 470-478.			
2.	/G.E./	S. Amoruso et al., "Characterization of Laser-Ablation Plasmas", J. Phys. B: At. Mol. Opt. Phys. 32 (1999) R131-R172, section 2.1.1.			
3.	/G.E./	Kautek et al., Laser Ablation of Dielectrics with Pulse Durations Between 20 fs and 3 ps, Appl. Phys. Lett. 69(21), November 18, 1996, pages 3146-3148.			
4.	/G.E./	J. Bonse et al., Ultrashort-Pulse Laser Ablation of Indium Phosphide in Air, Appl. Phys. A Volume 72, Issue 1, pages 89-94 (2001)			
5.	/G.E./	S. Preuss et al., Time Resolved Dynamics of Subpicosecond Laser Ablation, Appl. Phys. Lett, Vol. 62, No. 23, June 7, 1993			
6.	/G.E./	Schwab et al., Femtosecond-Excimer-Laser Patterning of YBa2 Cu3 O7 Films, Appl. Phys. A, Volume 53, (1991), pages 282-283.			
7.	/G.E./	Chen et al., Generation of Submicron Surface Gratings on LiNbO3 by Ultrashort UV Laser Pulses, Appl. Phys. A, Volume 65, Pages 517-518 (1997).			

Examiner: /Geoffrey Evans/ Date Considered: 07/09/2007